

AF



RESPONSE UNDER 37 CFR §1.116  
EXPEDITED PROCEDURE  
GROUP ART UNIT 2800

PATENT

9/B (FE)  
G. Stucky  
6-26-03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Kiyoshi ARITA et al.

Serial No.: 10/036,485

Filed: January 7, 2002

For: PLASMA PROCESSING METHOD

Group Art Unit: 2829

Examiner: Scott B. Geyer

M. Bauman  
7/31/02

AMENDMENT UNDER 37 CFR §1.116

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

In response to the Office Action mailed April 10, 2003,  
please amend the above-identified application as follows:

PLEASE ACCEPT THIS AS  
AUTHORIZATION TO DEBIT  
OR CREDIT FEES TO  
DEP. ACCT. 16-0331  
PARKHURST & WENDEL

RECEIVED  
JUN 25 2003  
TECHNOLOGY CENTER 2800